

DOCKET NO: 212812US2

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

#21
RECEIVED

MAR 22 2004

OFFICE OF PETITIONS

IN RE APPLICATION OF :
TAKASHI IPPOSHI, ET AL. : EXAMINER: NGUYEN, JOSEPH H.
SERIAL NO: 09/930,202 :
RCE FILED: HERewith : GROUP ART UNIT: 2815
FOR: SEMICONDUCTOR WAFER :

PETITION TO WITHDRAW THE APPLICATION FROM ISSUE
UNDER 37 CFR 1.313(c)(2)

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

This is a petition to withdraw the above-identified application from issue pursuant to 37 CFR 1.313(c)(2) so that the Request for Continued Examination (RCE) and the Information Disclosure Statement (IDS) filed with this Petition may be considered upon the granting of this Petition. This Petition is filed under 37 CFR 1.313(c) because the Issue Fee was paid on February 16, 2004. In this case, the references disclosed in the IDS were cited in a Preliminary Search Report for a French counterpart of the above-identified application. Applicants' representatives only became aware of this Search Report on February 23, 2004 and therefore could not have filed the IDS before paying the Issue Fee. Accordingly, it is requested that the Petition be granted and that the above-identified application be withdrawn from issue and that the IDS be considered.

03/23/2004 AXELLEY 00000012 09930202

01 FC:1460

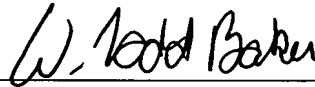
130.00 00

Application No. 09/930,202
Notice of Allowance of Dec. 16, 2003

In accordance with 37 CFR 1.17(h) the required fee for filing this 37 CFR 1.313
Petition is included herewith.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.



Gregory J. Maier
Attorney of Record
Registration No. 25,599
W. Todd Baker
Registration No. 45,265

Customer Number

22850

Tel: (703) 413-3000
Fax: (703) 413 -2220
(OSMMN 08/03)

I:\ATTY\WTB\2524\212812US\PETITION TO WITHDRAW ISSUE 15 MAR 04.DOC



Docket No.: 212812US2

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

RECEIVED

MAR 22 2004

OFFICE OF PETITIONS

RE: Application Serial No.: 09/930,202
Applicants: Takashi IPPOSHI, et al.
RCE Filing Date: Herewith
For: SEMICONDUCTOR WAFER
Group Art Unit: 2815
Examiner: NGUYEN, JOSEPH H.

SIR:

Attached hereto for filing are the following papers:

**PETITION TO WITHDRAW APPLICATION FROM ISSUE
REQUEST FOR CONTINUED EXAMINATION (RCE)
INFORMATION DISCLOSURE STATEMENT**

PTO-1449 W/7 REFERENCES AND 1 FRENCH SEARCH REPORT

Our check in the amount of \$900.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Gregory J. Maier

Registration No. 25,599

Customer Number

22850

(703) 413-3000 (phone)

(703) 413-2220 (fax)

I:\ATTY\WTB\2524\212812US\SH T PTO 15 MAR 04.DOC

W. Todd Baker

Registration No. 45,265